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PTO/PCT Rec'd 20 JUN 2002

#3

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

YASUJI HIRAMATSU ET AL

: ATTN: APPLICATION DIVISION

SERIAL NO: 10/069,510

:

FILED: March 4, 2002

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FOR: HOT PLATE FOR SEMICONDUCTOR
PRODUCING/EXAMINING DEVICE

*H. Klein
#3 Pre
Amend
11/19/2002*

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified application as follows:

IN THE TITLE

Please delete the current title and insert therefor:

HOT PLATE FOR SEMICONDUCTOR MANUFACTURE AND TESTING

IN THE CLAIMS

Please amend Claims 3 and 4 to read as follows:¹

¹A marked-up copy of the amendments is attached hereto.